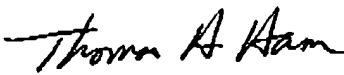
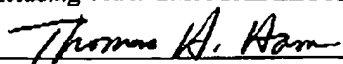


MAY 19 2006

AMENDMENT TRANSMITTAL LETTER Under Small Entity Status				Attorney Docket No: INK-002		
Application Serial Number: 10/829,593		Filing Date: 04/21/2004		Examiner: Rachuba, Maurina T.		Group Art Unit: 3723
Invention: APPARATUS AND METHOD FOR POLISHING SEMICONDUCTOR WAFERS USING ONE OR MORE POLISHING SURFACES						
TO THE COMMISSIONER OF PATENTS AND TRADEMARKS: Transmitted herewith is an amendment in the above-identified application. The fee has been calculated as shown below.						
CLAIMS AS AMENDED						
	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NUMBER PREVIOUSLY PAID FOR	NO. OF EXTRA CLAIMS PRESENT	RATE	ADDITIONAL FEE
TOTAL CLAIMS	113	MINUS	113	0	\$25	\$ 0.00
INDEP. CLAIMS	11	MINUS	11	0	\$100	\$ 0.00
_____ Petition is hereby made under 37 CFR 1.136(a) to extend the time for response to the Office Action _____ to and through _____, comprising an extension of the shortened statutory period of: <div style="display: flex; justify-content: space-around; margin-top: 10px;"> <div> _____ one month (\$60) _____ two months (\$225) </div> <div> _____ three months (\$510) _____ four months (\$795) </div> </div>						
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT						\$ 0.00
_____ Small entity status of this application under 37 CFR 1.9 and 1.27 has been established by a verified statement previously submitted. _____ A verified statement to establish small entity status under 37 CFR 1.9 and 1.27 is enclosed. _____ A check in the amount of \$ _____ is attached. _____ Charge \$ _____ to Deposit Account _____. <u> X </u> No additional fee is required.						
<u>May 19, 2006</u> Date		 Thomas H. Ham Reg. No. 43,654				
CERTIFICATE OF TRANSMISSION UNDER 37 C.F.R. 1.8 I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being facsimile transmitted to the Patent and Trademark Office facsimile number (571) 273-8300 on May 19, 2006. Number of Pages: <u>5</u> (including TRANSMITTAL LETTER) <div style="text-align: center; margin-top: 10px;">  Thomas H. Ham </div>						

Attorney Docket No. INK-002

PATENT APPLICATION

RECEIVED
CENTRAL FAX CENTER
MAY 19 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): In Kwon Jeong

Group Art Unit: 3723

Serial No. 10/829,593

Confirmation No. 6718

Filed: April 21, 2004

Examiner: Rachuba, Maurina T.

For: APPARATUS AND METHOD FOR POLISHING SEMICONDUCTOR
WAFERS USING ONE OR MORE POLISHING SURFACESMail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450RESPONSE TO FINAL OFFICE ACTION

Sir/Madam:

In response to the Final Office Action mailed on March 31, 2006, please consider the following **Remarks**, which begin on page 2 of this paper.

CERTIFICATE OF TRANSMISSION UNDER 37 C.F.R. 1.8

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being facsimile transmitted to the Patent and Trademark Office facsimile number (571) 273-8300 on May 19, 2006.

Number of Pages: 5 (including TRANSMITTAL LETTER)

Signed: Thomas H. Ham

Typed Name: Thomas H. Ham